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APPLICANTS									
Byoung Hee Cho, Ichon-Shi, KOREA, REPUBLIC OF;									
** CONTINUING DATA **********************************									
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ADDRESS 04743 MARSHALL, GERSTEIN & BORUN LLP 6300 SEARS TOWER 233 S. WACKER DRIVE CHICAGO, IL 60606									
TITLE Method for forming gate oxide in semiconductor device									
l N	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:				All Fees 1.16 Fees (Filing) 1.17 Fees (Processing Ext. of time)				